| TRA | NSMITTAL O | Docket No. OKI.586 | | | | | | | | | |
|---|--|--------------------|------------------|----------------|--|--|--|--|--|--|--|
| In Re Application Of: Tae YAMANE et al. | | | | | | | | | | | |
| | Serial No. | Filing Date | ADEMARK Examiner | Group Art Unit | | | | | | | |
| 10/681,283 | | October 9, 2003 | TBA | 2811 | | | | | | | |
| Title: SEMICONDUCTOR DEVICE AND FABRICATION METHOD OF THE SAME | | | | | | | | | | | |
| · · · · · · · · · · · · · · · · · · · | | | | | | | | | | | |
| Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 | | | | | | | | | | | |
| | | 37 C | FR 1.97(b) | | | | | | | | |
| 1. 🛚 | The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114. | | | | | | | | | | |
| | | 37 C | FR 1.97(c) | | | | | | | | |
| 2. | The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of: | | | | | | | | | | |
| | ☐ the statement specified in 37 CFR 1.97(e); | | | | | | | | | | |
| | OR | | | | | | | | | | |
| | ☐ the fee set forth in 37 CFR 1.17(p). | | | | | | | | | | |
| | ÷` | | | | | | | | | | |
| | : | | | | | | | | | | |
| | | | | | | | | | | | |

1

| TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c)) OKI.586 | | | | | | | | | | |
|---|--|------------|--|---|--|---|--|--|--|--|
| In Re Application: Tae YAMANE et al. | | | | | | | | | | |
| Serial No. | Filing Date | A TRAD | OK OFFIS | Examine | -uap Or | Group Art Unit | | | | |
| 10/681,283 | October 9, 2003 | 3 | EMAND | TBA | DEM | 2811 | | | | |
| SEMICONDUCTOR DEVICE AND FABRICATION METHOD OF THE SAME | | | | | | | | | | |
| Payment of Fee | | | | | | | | | | |
| (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) | | | | | | | | | | |
| as described belo Charge th Credit an Charge a Certificate of | ereby authorized to char ow. he amount of ny overpayment. any additional fee requir Transmission by Facsiment and authorization to char imile transmitted to the Union | red. nile* | I ce on as add | Certificate of Mailinertify that this documen | nt and fee is b with the U.S. der 37 C.F.F ssioner for Pal 313-1450. | being deposited Postal Service R. 1.8 and is stents, P.O. Box | | | | |
| Typed or Printed N | Name of Person Signing Certif | ficate | | Typed or Printed Name o | of Person Mail | ing Certificate | | | | |
| ADAM C. VOLENTINE REG. NO. 33,289 VOLENTINE FRANCOS, 12200 SUNRISE VALLEY | | ; by | Dated: | January 26, 2004 | | | | | | |
| RESTON, VA 20191 | | | | | | | | | | |
| TEL. NO. (703)715-0870 | | | | | | | | | | |

Application Number Docket Number (Optional) OKI.586 10/681,283 INFORMATION DISCLOSURE CITATION Applicant(s) (Use several sheets if mec ssats) Tae YAMANE et al. Filing Date Group Art Unit Oct ber 9, 2003 2811 JAN 2 6 ZUUS **U.S. PATENT DOCUMENTS** DOCUMENT NUMBER EXAMINER FILING DATE SUBCLASS REF NAME CLASS INITIAL IF APPROPRIATE 02/19/2002 6,348,728 AIBA et al. 6,400,021 06/04/2002 **CHO** В TAKAHASHI et al. C 2001/0038151 A1 11/08/2001 FOREIGN PATENT DOCUMENTS Translation REF DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS YES NO D 2002064163 A 02/28/2002 **JAPAN** Alstraci 2001144197 A **JAPAN** E 05/25/2001 04/12/2002 **JAPAN** 2002110898 A OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) **EXAMINER** DATE CONSIDERED EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

E